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PATENT
ATTORNEY DOCKET: 46884-5314

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)
)
Takayoshi HONMA et al.) Confirmation No.: 1802
)
Application No.: 10/506,508) Group Art Unit: 2814
)
Filed: September 3, 2004) Examiner: John C. Ingham
)
For: SEMICONDUCTOR LIGHT EMITTING)
DEVICE AND PLANT CULTIVATING)
SYSTEM)

Commissioner for Patents
U.S. Patent and Trademark Office
Customer Window, Mail Stop Amendment
Alexandria, VA 22314

Sir:

**SUBMISSION OF CERTIFIED
TRANSLATION OF PRIORITY DOCUMENT**

Applicants submit the enclosed certified English-language translation of Japanese Patent Application No. P2002-060854 filed March 6, 2002, the priority of which is claimed in the above-identified application. Applicants submit that the March 6, 2002 filing date for this document precedes the June 13, 2002 publication date of the PCT Publication No. WO 02/47224 for the applied Hennig et al. patent. At least for the reasons discussed in the previous Office Action, a favorable determination is awaited.

EXCEPT for issue fees payable under 37 C.F.R. § 1.18, the Commissioner is hereby authorized by this paper to charge any additional fees during the entire pendency of this application including fees due under 37 C.F.R. § 1.16 and 1.17 which may be required, including any required extension of time fees, or credit any overpayment to Deposit Account No. 50-0573.

This paragraph is intended to be a **CONSTRUCTIVE PETITION FOR EXTENSION OF TIME** in accordance with 37 C.F.R. § 1.136(a)(3).

Respectfully submitted,

Dated: November 20, 2006



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